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**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Koos et al.

Application No.: 10/690,084

Filed: October 20, 2003

Title: METHOD FOR FABRICATION OF  
SEMICONDUCTOR INTERCONNECT  
STRUCTURE WITH REDUCED CAPACITANCE,  
LEAKAGE CURRENT, AND IMPROVED  
BREAKDOWN VOLTAGE



Attorney Docket No.:  
NOVLP068/NVLS-2818

Examiner: Vinh, Lan

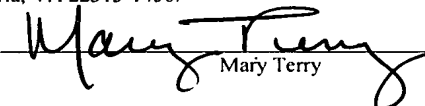
Group: 1765

Confirmation No.: 4873

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the U.S. Postal Service with sufficient postage as first-class mail on July 25, 2007 in an envelope addressed to the Commissioner for Patents, P.O. Box 1450 Alexandria, VA 22313-1450.

Signed: \_\_\_\_\_

  
Mary Terry

**INFORMATION DISCLOSURE STATEMENT  
37 CFR §§1.56 AND 1.97(b)**

Mail Stop Amendment  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Dear Sir:

The reference(s) identified in the attached PTO Form 1449 (copies of non-U.S. references are attached) may be material to examination of the above-identified patent application.

Applicants identify these reference(s) in compliance with their duty of disclosure pursuant to 37 CFR §§1.56 and 1.97. The Examiner is requested to make the identified reference(s) of official record in this application.

This Information Disclosure Statement is not to be construed as a representation that a search has been made, that additional information material to the examination of this application does not exist, or that the identified reference(s) indeed constitute prior art.

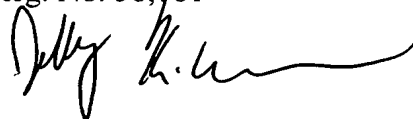
This Information Disclosure Statement is: (i) filed within three (3) months of the filing date of the above-referenced application, (ii) believed to be filed before the mailing date of a first Office Action on the merits, or (iii) believed to be filed before the mailing of a first Office Action after the filing of a Request for Continued Examination under §1.114. Accordingly, it is believed that no fees are due in connection with the filing of this Information Disclosure

Statement. However, if it is determined that any fees are due, the Commissioner is hereby authorized to charge such fees to Deposit Account 500388 (Order No. NOVLP068 ).

Respectfully submitted,  
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<b>Form 1449 (Modified)</b>  <b>Information Disclosure Statement By Applicant</b>  (Use Several Sheets if Necessary)	<b>Atty Docket No.</b>	NOVLP068/NVLS-2818
	<b>Application No.:</b>	10/690,084
	<b>Applicant</b>	Koos et al.
	<b>Filing Date</b>	October 20, 2003
	<b>Group</b>	1765
		Page 1 of 1

#### U.S. Patent Documents

Examiner Initial	No.	Patent No.	Date	Patentee	Class	Sub-class	Filing Date
	1.						
	2.						
	3.						

#### Foreign Patent or Published Foreign Patent Application

Examiner Initial		Document No.	Publication Date	Country or Patent Office	Class	Sub-Class	Translation	
							Yes	No
	4.							

#### Other Documents

Examiner Initial	No.	Author, Title, Place (e.g. Journal) of Publication, Date
	5.	U.S. Final Office Action mailed July 18, 2007 from U.S. Application No. 11/251,353. [NOVLP141/NVLS-3107]
	6.	SanderKok.com, "Analytical Chemistry", <a href="http://home.planet.nl/~skok/techniques/laboratory/pka_pkb.htm">http://home.planet.nl/~skok/techniques/laboratory/pka_pkb.htm</a> .

<b>Examiner</b>	<b>Date Considered</b>
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Examiner: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.